



Attorney's Docket No.: 042390P11354

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent

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TC 1700

In Re Application of:

Liang, Ted et al.

U.S. Serial No: 09/895,511

Filed: June 29, 2001

For: MASK REPAIR WITH  
ELECTRON BEAM-INDUCED  
CHEMICAL ETCHING

Examiner: Zervignon, Rudy

Art Unit: 1763

Commissioner for Patents  
P. O. 1450  
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Applicants respectfully request that this Preliminary Amendment be entered prior to examination of the above-identified patent application.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on January 26, 2004

Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

*Teresa Edwards*  
Signature

*January 26, 2004*  
Date